

<p style="text-align: center;">O P E FEB 08 2002 PATENT & TRADEMARK OFFICE</p>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO JM32810-CIP	SERIAL NO 10 046,330
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Wuwen Yi et al	
				FILING DATE October 25, 2001	PRIORITY GROUP 2818
				U.S. PATENT DOCUMENTS	

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
PD	AA	6,214,177 B1	04/01	Runkle	—	—	
	AB	5,294,321	03/94	Satou et al	—	—	
	AC	5,612,571	03/97	Satou et al	—	— C	
	AD	5,464,520	11/95	Kano et al	—	—	
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		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
EXAMINER	PHUC T DANG			DATE CONSIDERED		2/15/2003	

*EXAMINER Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.